

NEW APPLICATION TRANSMITTAL - UTILITY

Transmitted herewith for filing is the patent application of Tony CHIEN for
"ALIGNMENT MARK AND ALIGNMENT METHOD USING THE SAME FOR
PHOTOLITHOGRAPHY TO ELIMINATING PROCESS BIAS ERROR".

1. Type Of Application

This application is an original utility application.

2. Benefit Of Prior Application

Priority is claimed based on Taiwan application serial no. 92121221, filed Aug. 1,
2003.

3. Fee Calculation

CLAIMS AS FILED			
			Basic Fee = \$770.00
Total:	18 - 20 = 0	x \$18.00 =	0.00
Ind.:	4 - 3 = 1	x \$86.00 =	86.00
Multiple dependent:	0	x \$290.00 =	<u>0.00</u>

Basic Filing Fee Calculation = \$856.00

4. Fee Payment Being Made At This Time

Required Fees:

x Basic Filing Fee \$856.00

Total Fees \$856.00

Please charge the above and any deficiencies in fees to Deposit Acct # 16-2497.

031356 U.S. PTO
10/750805
010204

5. Papers Enclosed Which Are Required For Filing Date Under 37 CFR 1.53(b)

10 Pages of specification

4 Pages of claims

1 Page of abstract

4 Sheets of formal drawings


6. Declaration or Oath

A Combined Declaration and Power of Attorney executed by each inventor is enclosed herewith.

7. Certificate of Mailing (37 CFR 1.10) : I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as Express Mail in an envelope addressed to: Mail Stop New Applications, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Respectfully submitted,

Date: January 2, 2004



Keith Kline

PRO-TECHTOR INTERNATIONAL
20775 Norada Court
Saratoga, CA 95070-3018

Registration No: 32,737
Telephone: (408) 778-3440